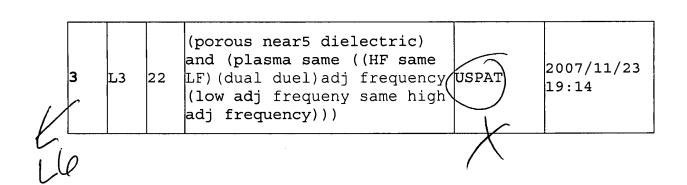
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<b>1</b> L1 65	("20020001973"   "20020016085 "   "20020034626"   "2002006434 1"   "20020106500"   "200201232 40"   "20020141024"   "20020192 980"   "20030064607"   "2003011 9307"   "20030157248"   "200301 98895"   "20040069410"   "20040 096586"   "20040096593"   "2004 0096672"   "20040099952"   "200 40101633"   "20040170760"   "2 0040185679"   "20050064698"   " 4357451"   "4882008"   "4885262 "   "5504042"   "5686054"   "5700 844"   "5789027"   "5849640"   "5 851715"   "5858457"   "5920790"   "6140252"   "6171661"   "61773 29"   "6232658"   "6258735"   "62 68276"   "6268288"   "6270846"   "6271273"   "6312793"   "632901 7"   "6329062"   "6340628"   "636 5266"   "6383466"   "6383955"   "6386466"   "6387453"   "6596654"   "657070"   "6548113"   "6558755"   "6573030"   "6576300"   "65763 45"   "6596467"   "6596654"   "66 10362"   "6632478"   "6667147"   "6677251"   "6715498"   "675608 5"   "6759098"   "6797643"   "680 5801"   "6812043"   "6815373"   "6831284"   "6867086"   "6903 004"   "6914014"   "7018918"   "7 094713"   "7166531"   "7176144"   ) . PN.	USPAT	2007/11/23	Le
<b>2</b> L2 1	L1 and (plasma same ((HF same LF) (dual duel)adj frequency (low adj frequeny same high adj frequency)))	USPAT	2007/11/23 19:14	

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4	L4		("20020001973"   "20020016085 "   "20020034626"   "20020016085 "   "20020106500"   "200201232 40"   "20020141024"   "20020192 980"   "20030064607"   "2003011 9307"   "20030157248"   "200301 98895"   "20040069410"   "20040 096586"   "20040096593"   "2004 0096672"   "20040099952"   "200 40101633"   "20040102031"   "20 40101633"   "20040170760"   "2 0040185679"   "20050064698"   " 4357451"   "4882008"   "4885262 "   "5504042"   "5686054"   "5700 844"   "5789027"   "5849640"   "5 851715"   "5858457"   "5920790"   "6140252"   "6171661"   "61773 29"   "6232658"   "6258735"   "62 68276"   "6268288"   "6270846"   "6271273"   "6312793"   "632901 7"   "6329062"   "6340628"   "636 5266"   "6383466"   "6383955"   "6386466"   "6387453"   "6391932 "   "6573030"   "6576300"   "65763 45"   "6596467"   "6596654"   "66 10362"   "6632478"   "6667147"   "6677251"   "6759098"   "6797643"   "680 5801"   "6812043"   "6815373"   "6831284"   "6846380"   "684848458 "   "6849549"   "6867086"   "6903 004"   "6914014"   "7018918"   "7 094713"   "7166531"   "7176144"   ) .PN.	USPAT;	2007/11/23 19:14
5	L5	1	frequency (low add frequent	US-PGPUB; USPAT; USOCR	2007/11/23 19:15

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6	L6	(porous near5 dielectric) and (plasma same ((HF same LF) (dual duel) adj frequency (low adj frequeny same high adj frequency)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2007/11/23 19:15 .

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Time: 18:12:10



## **PALM INTRANET**

## **Inventor Information for 10/807680**

Inventor Name	City	State/Country
WU, QINGGUO	TUALATIN	OREGON
<u>FU, HAIYING</u>	WEST LINN	OREGON
MUIR, TIMOTHY J.	TIGARD	OREGON
Appln Info Contents Petition In	fo Atty/Agent Info	Continuity/Reexam Foreign

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Attorney Docket #	Search
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### **Inventor Name Search Result**

Your Search was:

Last Name = WU

First Name = QINGGUO

Application#	Patent#	Status	Date Filed	Title	Inventor Name
10624959	7112615	150	07/22/2003	POROUS MATERIAL FORMATION BY CHEMICAL VAPOR DEPOSITION ONTO COLLOIDAL CRYSTAL TEMPLATES	WU, QINGGUO
10672311 505	7208389	150	09/26/2003	METHOD OF POROGEN REMOVAL FROM POROUS LOW-K FILMS USING UV RADIATION	WU, QINGGUO
10789103 105	Not Issued	41	02/27/2004	Methods for producing low-k CDO films with low residual stress	WU, QINGGUO
10800409 105	Not Issued	100	03/11/2004	METHODS FOR PRODUCING LOW-K CDO FILMS	WU, QINGGUO
10807680	Not Issued	30	03/23/2004	Methods of porogen removal for porous low dielectric constant films using plasma treatments	WU, QINGGUO
10820525 JDS	Not Issued	41	04/07/2004	Methods for producing low-k CDO films with low residual stress	WU, QINGGUO
10849568 SLD S	Not Issued	71	05/18/2004	Method for improving mechanical properties of low dielectric constant materials	WU, QINGGUO
10927777 J	7241704	150	08/27/2004	METHODS FOR PRODUCING LOW STRESS POROUS LOW- K DIELECTRIC MATERIALS USING PRECURSORS WITH ORGANIC FUNCTIONAL GROUPS	WU, QINGGUO
10941502 IV	Not Issued	99	09/14/2004	METHODS FOR IMPROVING INTEGRATION PERFORMANCE OF LOW STRESS CDO FILMS	WU, QINGGUO
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ı	1		ı <b>ı</b>	11 1	I	
	11369658 To 5	Not Issued	30		Methods for fabricating high hardness/modulus low dielectric constant materials	WU, QINGGUO
	11608056 TD 5	Not Issued	30	12/07/2006	PECVD METHODS FOR PRODUCING ULTRA LOW-K DIELECTRIC FILMS USING UV TREATMENT	WU, QINGGUO
	11693661 IDS	Not Issued	30	03/29/2007	METHODS FOR IMPROVING PERFORMANCE OF ODC FILM WITH DIELECTRIC CONSTANT < 4.0	WU, QINGGUO
ار اور کرد ار اور کرد	(11764750)	Not Issued	41	06/18/2007	METHODS FOR PRODUCING LOW STRESS POROUS LOW- K DIELECTRIC MATERIALS USING PRECURSORS WITH ORGANIC FUNCTIONAL GROUPS	WU, QINGGUO
<b>'</b>	11936752 2 milhoh	Not Issued 34	19	01/01/0001	METHODS FOR IMPROVING INTEGRATION PERFORMANCE OF LOW STRESS CDO FILMS	WU, QINGGUO
	11936754	Not Issued	19	01/01/0001	METHODS FOR PRODUCING LOW-K CDO FILMS	WU, QINGGUO
/	60397747	Not Issued	159	07/22/2002	Chemical vapor deposition onto colloidal crystal templates	WU, QINGGUO
	60524330	Not Issued	159	11/20/2003	Methods for producing low-k CDO film of low residue stress with dielectric constant < 3.0	WU, QINGGUO
	60852635	Not Issued	160	10/17/2006	PECVD method for producing ultra low-k dielectric films using UV treatment	WU, QINGGUO
	60949204	Not Issued	20	07/11/2007	METHODS FOR FABRICATING ZEOLITE NANO-CRYSTAL BASED LOW-K DIELECTRIC FILMS CONTAINING SI(CxHy)n GROUPS AND TREATING FILMS BY ULTRA-VIOLET THERMAL PROCESSING	WU, QINGGUO`

Inventor Search Completed: No Records to Display.

Soarch Another Inventor	Last Name	First Name	
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#### **Inventor Name Search Result**

Your Search was:

Last Name = FU

First Name = HAIYING

Application#	Patent#	Status	Date Filed	Title	Inventor Name
10099232	6764952	150	03/13/2002	SYSTEMS AND METHODS TO RETARD COPPER DIFFUSION AND IMPROVE FILM ADHESION FOR A DIELECTRIC BARRIER ON COPPER .	FU, HAIYING
10184681 2003017	6777349 <b>0</b> % ()	150	06/28/2002	HERMETIC SILICON CARBIDE	FU, HAIYING
(10334350) - July	6855645	150	12/30/2002	SILICON CARBIDE HAVING LOW DIELECTRIC CONSTANT	FU, HAIYING
10672311 195	7208389	150	09/26/2003	METHOD OF POROGEN REMOVAL FROM POROUS LOW-K FILMS USING UV RADIATION	FU, HAIYING
10789103	. Not Issued	41	02/27/2004	Methods for producing low-k CDO films with low residual stress	FU, HAIYING
10800409 105	Not Issued	100	11	METHODS FOR PRODUCING LOW-K CDO FILMS	FU, HAIYING
10807680	Not Issued	30	03/23/2004	Methods of porogen removal for porous low dielectric constant films using plasma treatments	FU, HAIYING
10820525 TVS	Not Issued	41	04/07/2004	Methods for producing low-k CDO films with low residual stress	FU, HAIYING
10825888 JD5	7253125	150	04/16/2004	METHOD TO IMPROVE MECHANICAL STRENGTH OF LOW-K DIELECTRIC FILM USING MODULATED UV EXPOSURE	FU, HAIYING
10860340 TOS	7094713	150	06/02/2004	METHODS FOR IMPROVING THE CRACKING RESISTANCE	FU, HAIYING

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					OF LOW-K DIELECTRIC MATERIALS	
:	10869474	7282438	150		LOW-K SIC COPPER DIFFUSION BARRIER FILMS	FU, HAIYING
	10927777 IJS	7241704	150	1	METHODS FOR PRODUCING LOW STRESS POROUS LOW-K DIELECTRIC MATERIALS USING PRECURSORS WITH ORGANIC FUNCTIONAL GROUPS	FU, HAIYING
·	10941502 DDS	Not Issued	99	09/14/2004	METHODS FOR IMPROVING INTEGRATION PERFORMANCE OF LOW STRESS CDO FILMS	FU, HAIYING
	10982654 TDS	Not Issued	30	11/05/2004	Methods of improving porogen removal and film mechanical strength in producing ultra low-k carbon doped oxide films using radical photopolymerization	FU, HAIYING
	11369658 FB	Not Issued	30		Methods for fabricating high hardness/modulus low dielectric constant materials	FU, HAIYING
	11376510	Not Issued	93	03/14/2006	METHODS FOR IMPROVING THE CRACKING RESISTANCE OF LOW-K DIELECTRIC MATERIALS	FU, HAIYING
	11693661 ID 5	Not Issued	30		METHODS FOR IMPROVING PERFORMANCE OF ODC FILM WITH DIELECTRIC CONSTANT < 4.0	FU, HAIYING
MOM	11764750	Not Issued	41	06/18/2007	METHODS FOR PRODUCING LOW STRESS POROUS LOW-K DIELECTRIC MATERIALS USING PRECURSORS WITH ORGANIC FUNCTIONAL GROUPS	FU, HAIYING
to lynn	11824049	Not Issued	30	06/28/2007	Method to improve mechanical strength of low-K dielectric film using modulated UV exposure	FU, HAIYING
γν	11893490	Not Issued	25		Low-k sic copper diffusion barrier films	FU, HAIYING
Mad	11936752	Not Issued	19	01/01/0001	METHODS FOR IMPROVING INTEGRATION PERFORMANCE OF LOW STRESS CDO FILMS	FU, HAIYING
WOR	11936754	Not	19	01/01/0001	METHODS FOR PRODUCING	FU, HAIYING
11/4						



	Issued		LOW-K CDO FILMS	
60524330	Not Issued	159	Methods for producing low-k CDO film of low residue stress with dielectric constant < 3.0	FU, HAIYING

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#### **Inventor Name Search Result**

Your Search was:

Last Name = MUIR

First Name = TIMOTHY

	Application#	Patent#	Status	Date Filed	Title	Inventor Name
/	10807680	Not Issued	30		Methods of porogen removal for porous low dielectric constant films using plasma treatments	MUIR, TIMOTHY J.

Inventor Search Completed: No Records to Display.

Soomah Amatham Invantam	Last Name	First Name	
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